Application 10/538,132						Our File No. P/2850-109							
INFORM STATE	MATION DISCLOSUR MENT BY APPLICAN	E IT	Applicant	Toshiyuki KAWAC	AGUCHI et al.								
(Use as many sheets as necessary) Filing			Filing Date	June 9, 2005 Group Art Unit 1773									
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not considered. Include copy of this form with next communication to the applicant.													

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